

# IPBSM status and plan

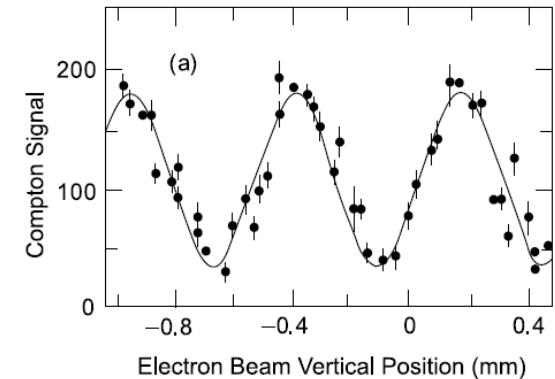
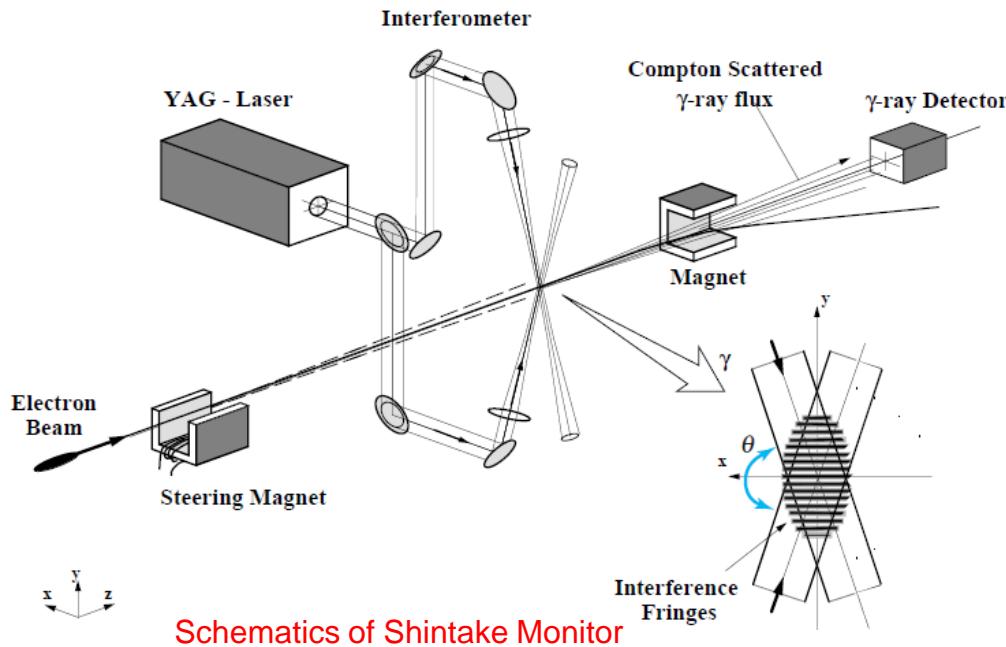
ATF project meeting

M.Oroku

# Principle of Laser Interference Beam Size Monitor (Shintake Monitor)

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# Shintake Monitor



Measured signal in FFTB at SLAC  
T. Shintake et al., 1992  
 $\sigma_y \sim 65$  nm beam size was measured

Modulation depth

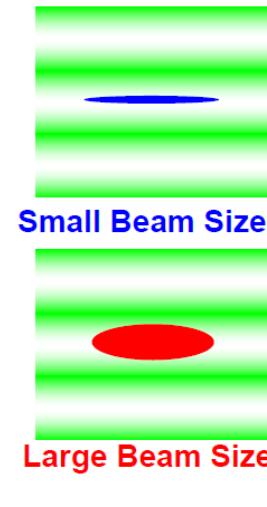
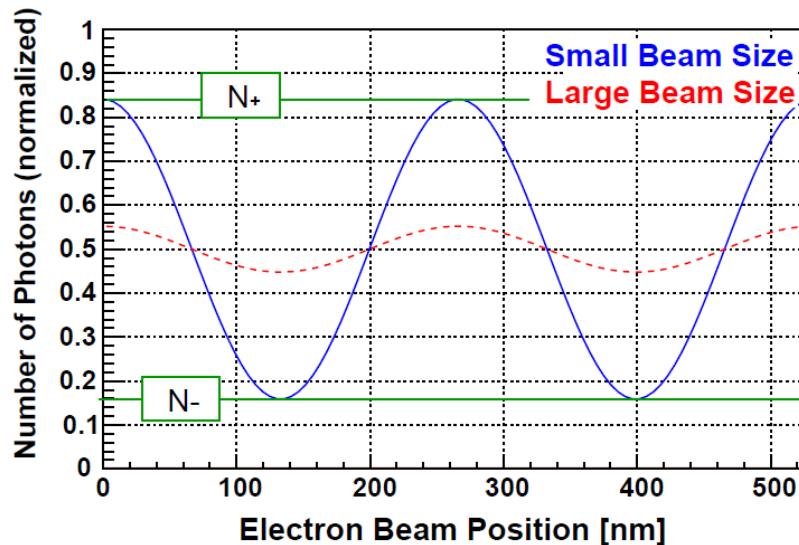
$$M \equiv \left| \frac{N_+ - N_-}{N_+ + N_-} \right| = \frac{\text{Amplitude}}{\text{Average}}$$

Beam Size

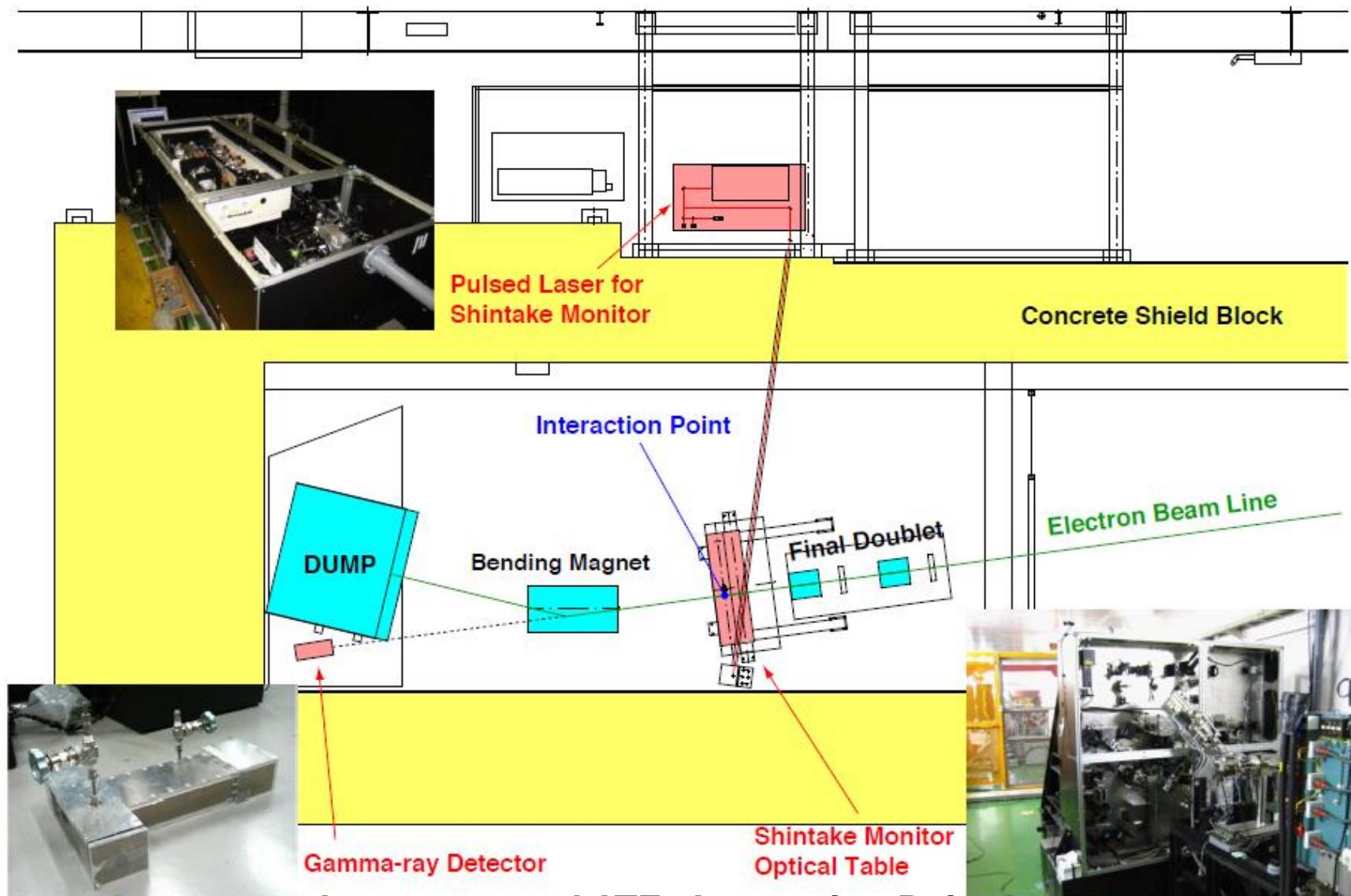
$$\sigma_y = \frac{d}{2\pi} \sqrt{2 \log \left( \frac{|\cos \theta|}{M} \right)}$$

$d$ : fringe pitch

$\theta$ : crossing angle



# Components of Shintake Monitor



# Laser System

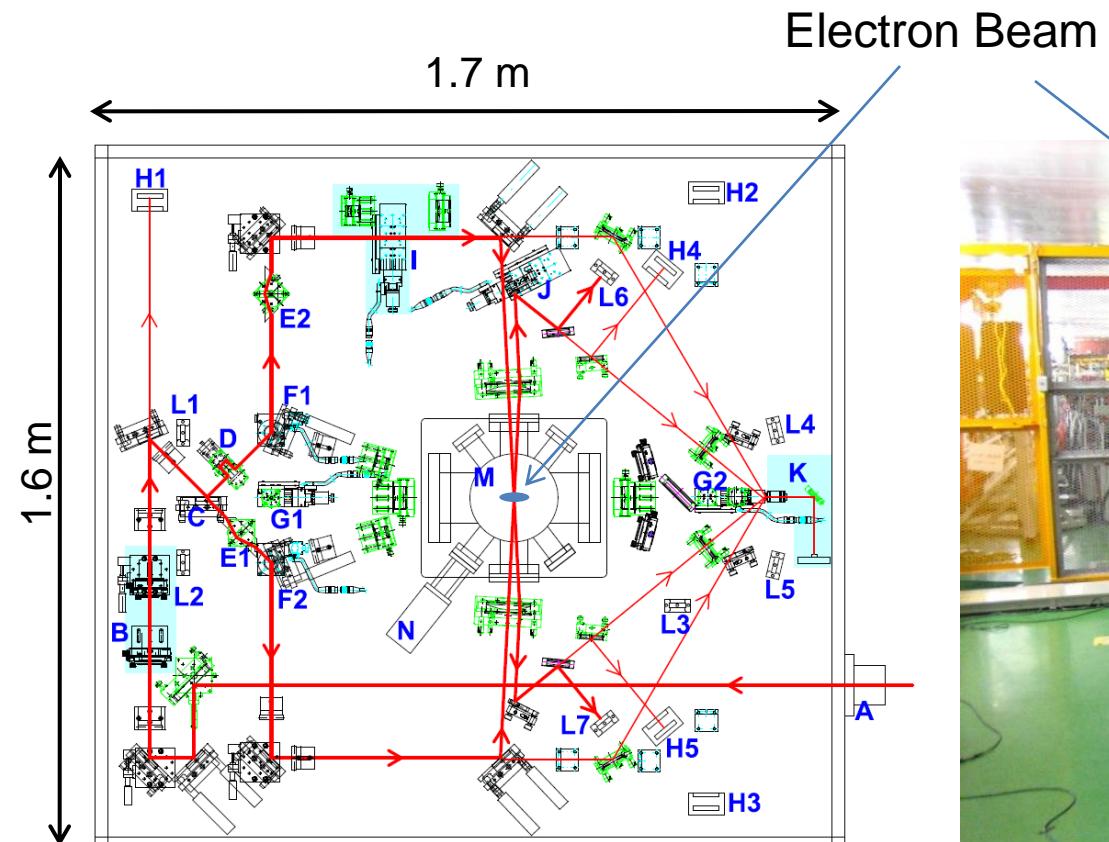


**Q-switched Nd:YAG Laser**  
(wave length:1064 nm)  
PRO350 (SpectraPhysics)

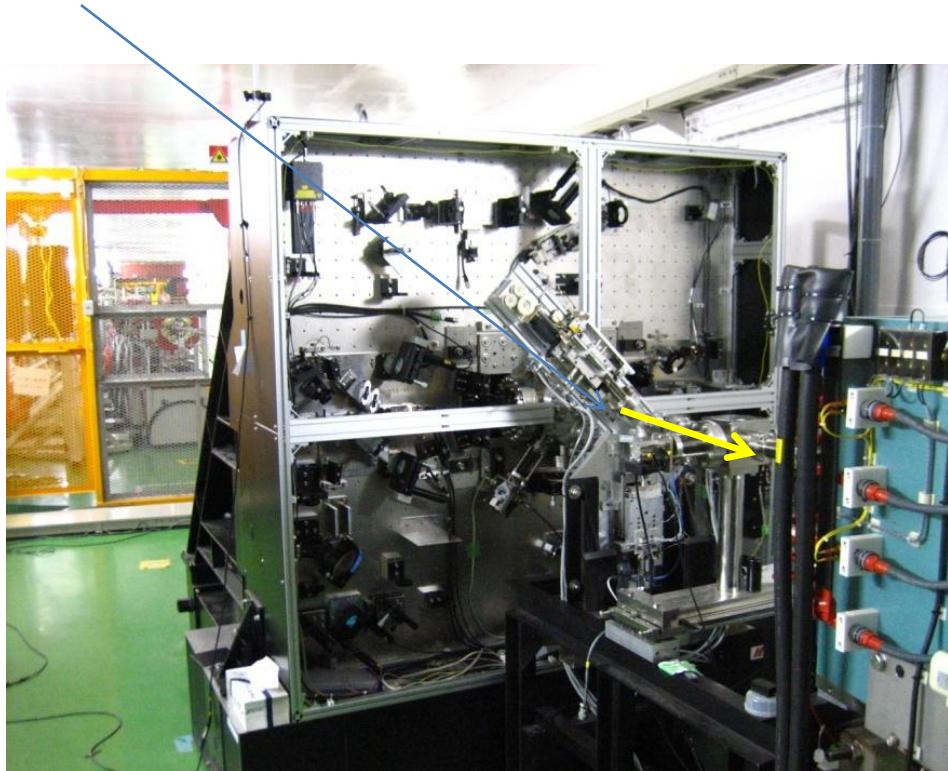
Specifications	Value
Wave length (second harmonics)	532 nm
Line width	< 0.003 cm <sup>-1</sup>
Repetition rate	6.25 Hz
Pulse width	8 ns (FWHM)
Timing jitter	< 1 ns (RMS)
Pulse energy	1.4 J/pulse

- To make smaller interference fringe, small wave length is needed.  
second harmonics 532nm
- High power laser is needed to raise S/N ratio.  
1.4J/pulse

# Vertical Optical Table



Laser path diagram (174 deg crossing angle)



Picture of the vertical optical table installed at ATF2 beam line

# Switch of Laser Crossing Angle

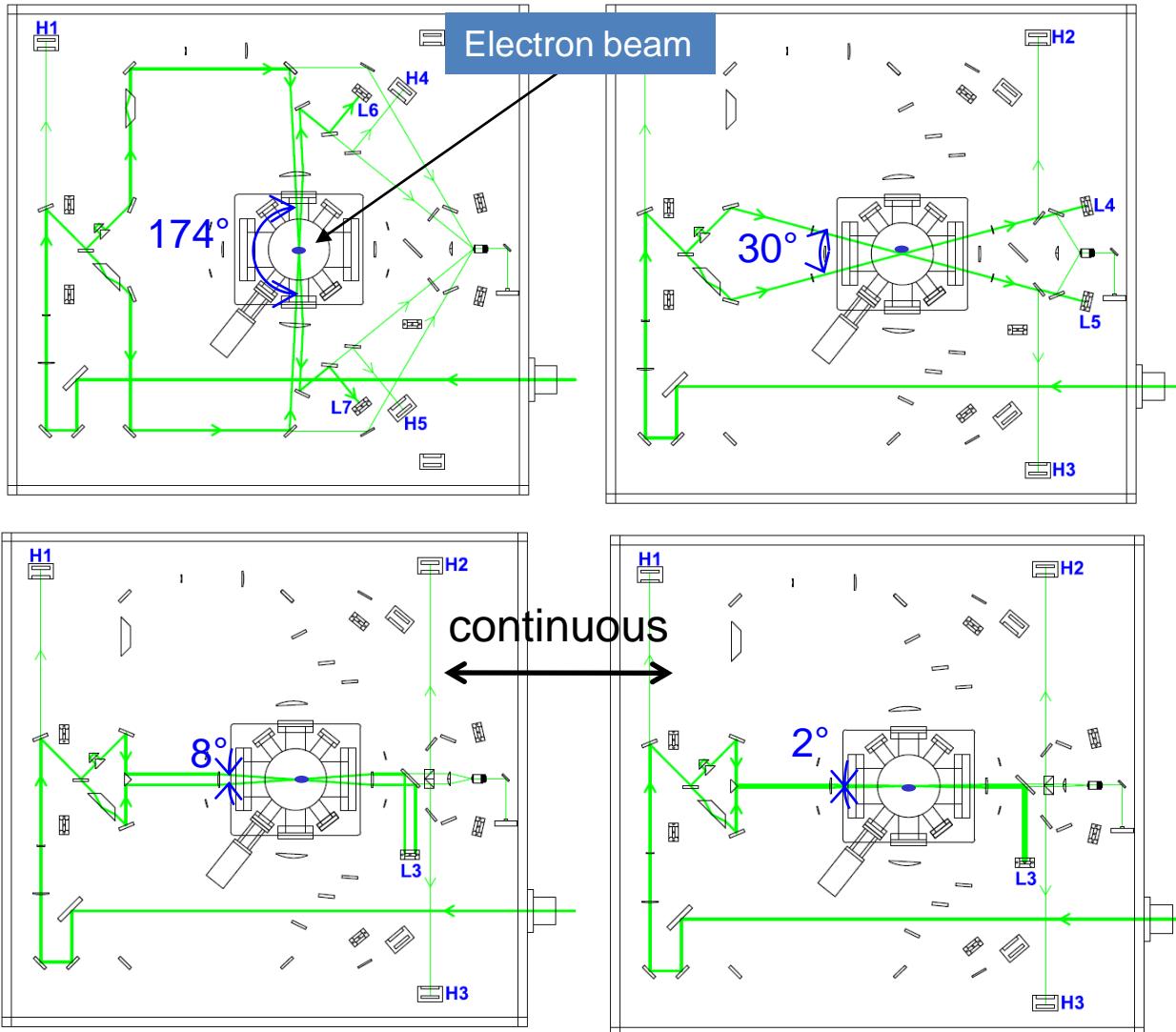
Issue of the Shintake Monitor  
 ⇒ measurable beam size range is limited  
 (7 – 40 % of fringe pitch),  
 if the fringe pitch is fixed.



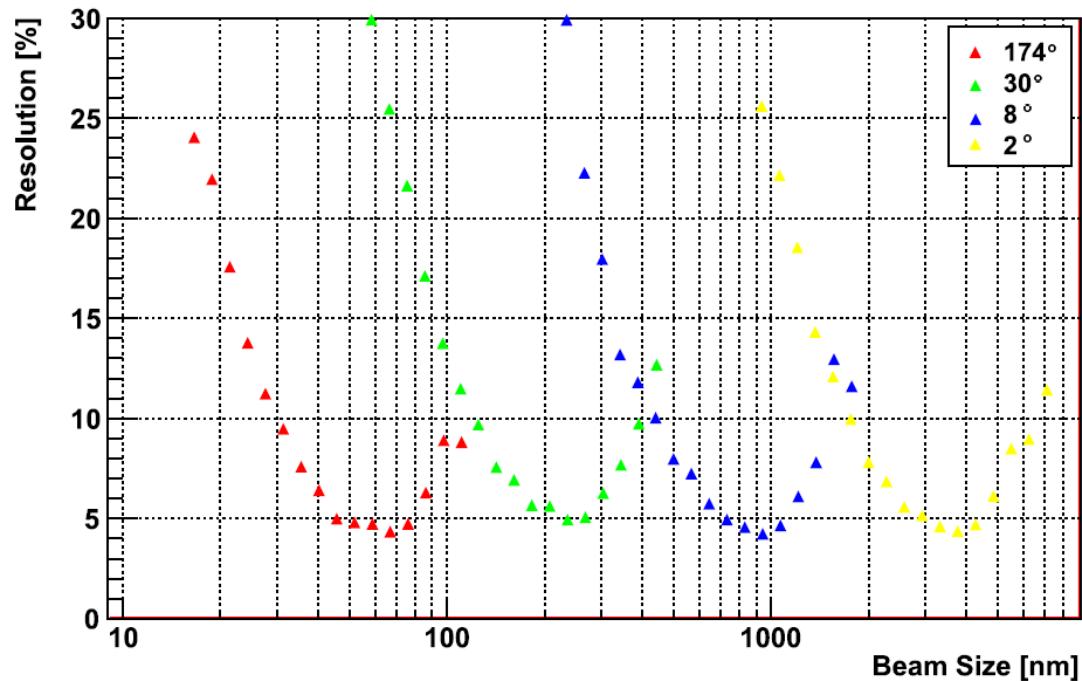
By changing the laser crossing angle,  
 the measurable beam size range can be enlarged.

$$\text{fringe pitch } d = \frac{\lambda}{\sin \frac{\theta}{2}}$$

$\theta$ : crossing angle



# Expected Beam Size Resolution



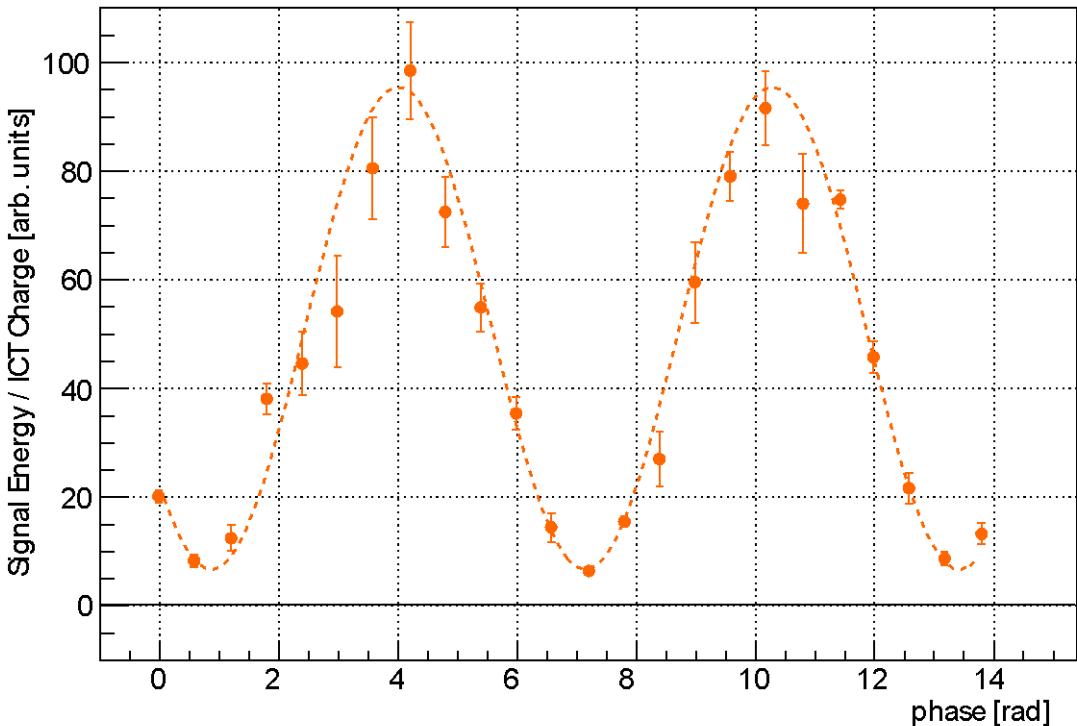
- ◆ Expected resolution (statistical error) is evaluated by simulation considering the probable error sources
  - ◊ in 25 nm ~ 6  $\mu\text{m}$  range : less than 12 %
- ◆ Systematic error also need to be evaluated.

**Simulation condition**

- Statistical error of the Compton scattered photons (including background subtraction): 10%
- Electron beam position jitter: 30 % of beam size
- Jitter of interference fringe phase: 400 mrad
- Jitter of laser pulse energy: 6.8%
- 1 measurement time . 1 min.

	174°	30°	8°	2°
Fringe pitch	266 nm	1.03 $\mu\text{m}$	3.81 $\mu\text{m}$	15.2 $\mu\text{m}$
Minimum	25 nm	100 nm	360 nm	-
Maximum	100 nm	360 nm	-	6 $\mu\text{m}$

# Result of continuous run



## Beam condition

- $\beta_x^* \sim 4$  cm (setting)
- $\beta_y^* \sim 1$  mm (setting)

• BG 6.5GeV

• S/N 30

## Measurement condition

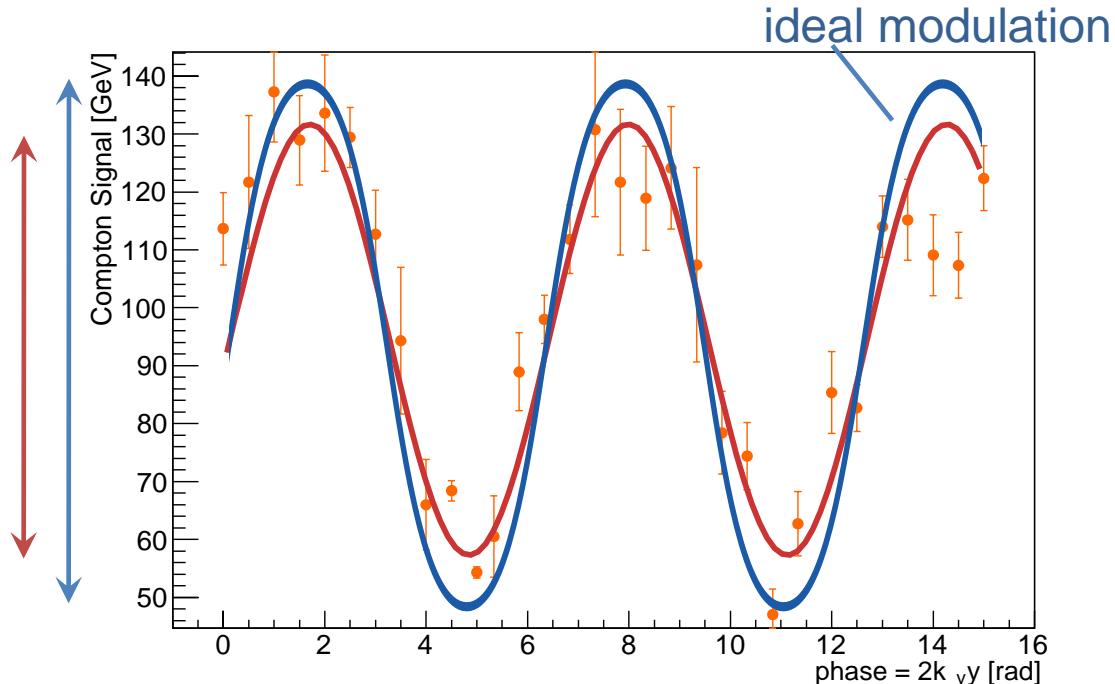
- Crossing angle  $\sim 7.96$  deg  
= fringe pitch  $\sim 3.83$   $\mu\text{m}$

Modulation  $\sim 0.85$

$$\sigma_y = 313 \pm 31 \text{ (stat.)} \begin{array}{l} +0 \\ -40 \end{array} \text{ (sys.) nm}$$

# Sources of Systematic Error

a error source:  
**deterioration of the  
 contrast of the laser  
 interference fringe  
 pattern**  
 ↓  
 decrease in  
 modulation depth



$$\text{Compton Signal} \propto 1 + M \cos 2k_y y$$

$$M_{\text{meas}} = C_\alpha C_\beta \cdots M_{\text{ideal}}$$

other error sources:  $e^-$  beam position jitter  
 $e^-$  beam size jitter  
 Tilt of the laser fringe pattern with respect to the  $e^-$  beam

# List of Error Sources

Source	$M_{\text{meas.}} / M_{\text{ideal}}$ for ~300nm	$M_{\text{meas.}} / M_{\text{ideal}}$ for 37nm
Laser power imbalance	99.7%	99.7%
Laser alignment accuracy	> 98.1%	> 98.1%
Laser temporal coherence	> 99.7%	> 99.7%
Phase jitter	> 99.5%	99.5 %*
Laser spherical wavefront	~ 100%	> 99.4%**
Beam size growth in the fringe pattern	~ 100%	99.9%***
$\Pi$ Factor	> 97%	96%

\* Beam position monitor is needed.

\*\* Laser focal point alignment is needed.

\*\*\* Beam optics study at upper and lower IP is needed.

# Towards the 37nm Beam Size Measurement

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Shintake Monitor

In future 37nm beam size measurement, following error sources cannot be neglected.

## Laser Spherical Wavefront

Alignment of laser focal point is needed.

## e<sup>-</sup> Beam Size Growth within the Fringe Pattern

We can estimate that influence from measurement of upper stream beam parameters and beam optical design.

## e<sup>-</sup> Beam Position Jitter

IP-BPM will enables us to correct beam position jitter in 8.7nm resolution.  
(assuming 30 nm beam jitter)

With evaluation of all error sources (include statistical errors), we evaluate the Shintake monitor performance towards 37nm beam size measurement.

$$\sigma_y = 37 \pm 4 \text{ (stat.)} \begin{array}{l} +0 \\ -2 \end{array} \text{ (sys.) nm}$$

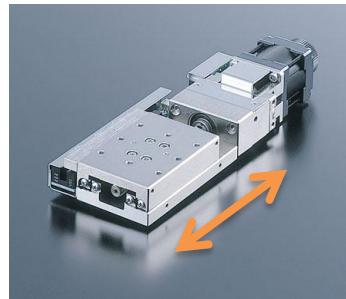
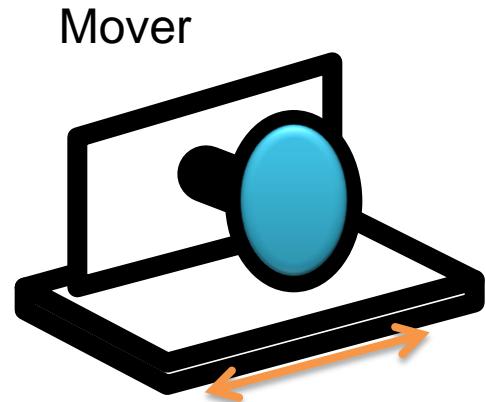
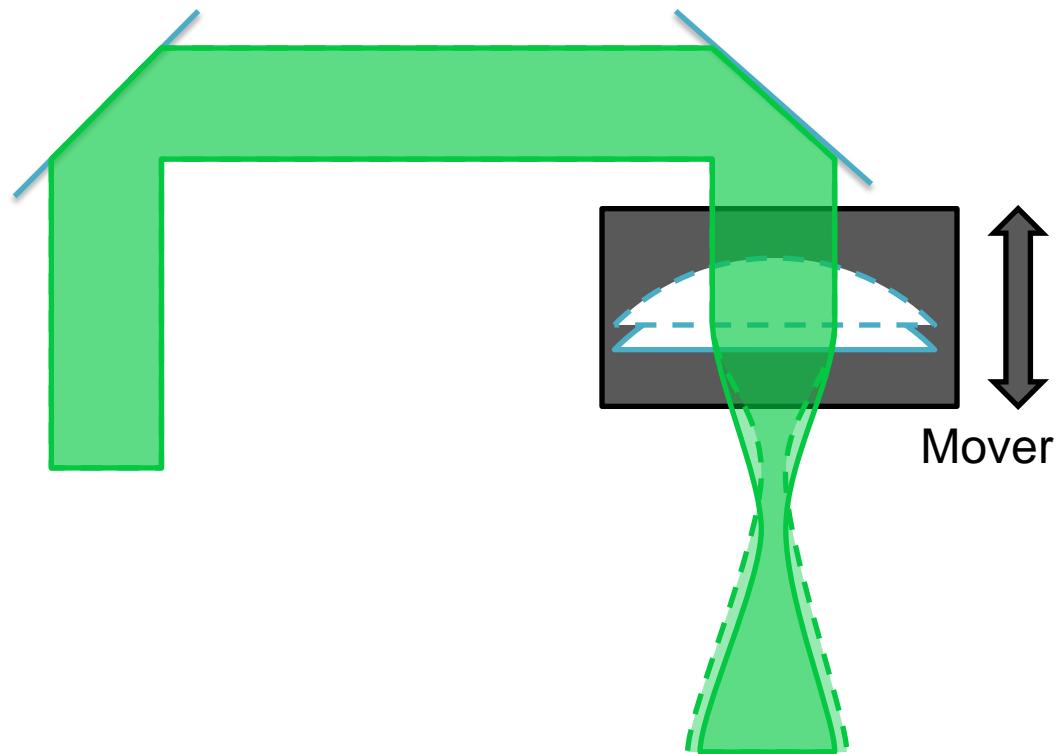
in 1 min. fringe scan

# Next Plan

- Focal point scan
- Phase Monitor
- Laser position stabilization with PSDs
- (Carbon wire scanner install)
- IPBPM install (need to discuss?)

# focal point scan(174deg)

Shintake Monitor



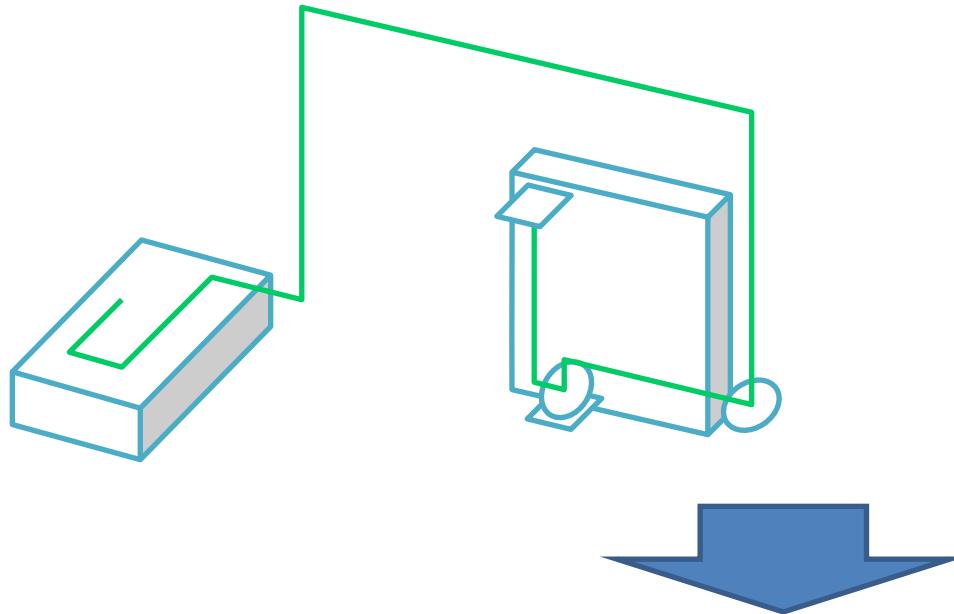
Stroke: 30mm  
Resolution 0.1 $\mu$ m

Offset of beam  
position to the focal  
point of laser



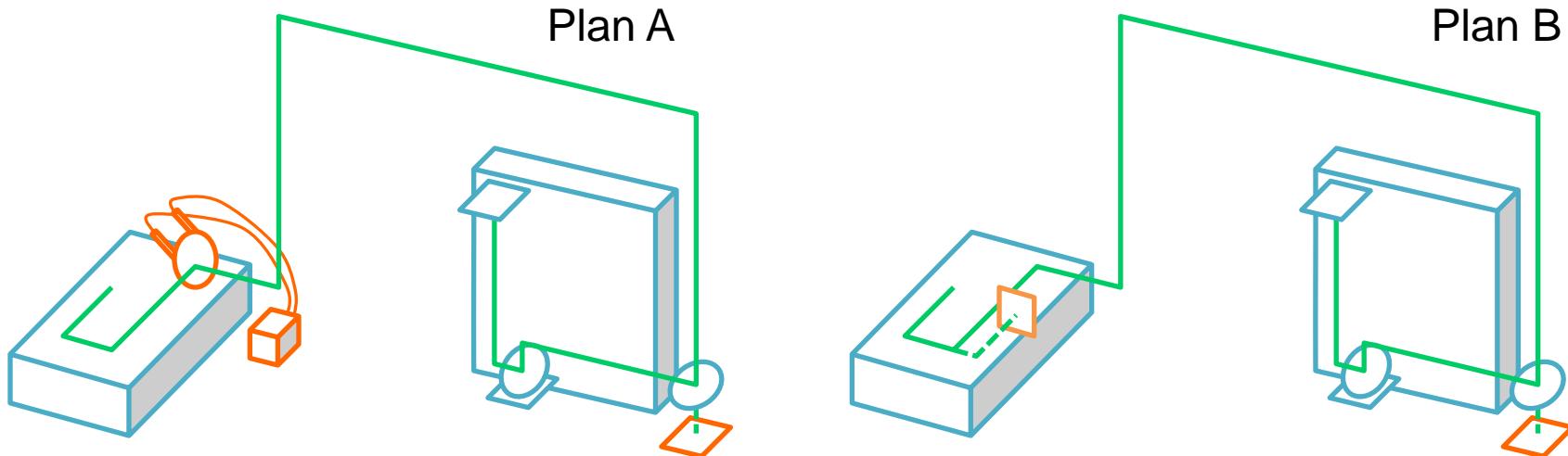
Systematic error  
from spherical  
wavefront of laser

# Laser position stabilization with PSDs (1)



To monitor the drift of  
laser position:

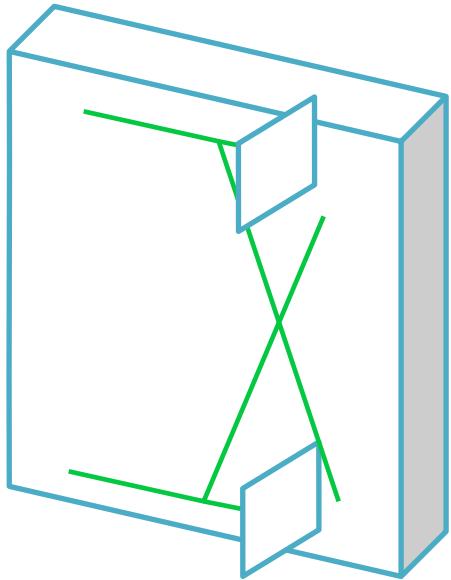
Put PSD at the end of  
long transport line  
↓  
Better stabilization



# Laser position stabilization with PSDs (2)

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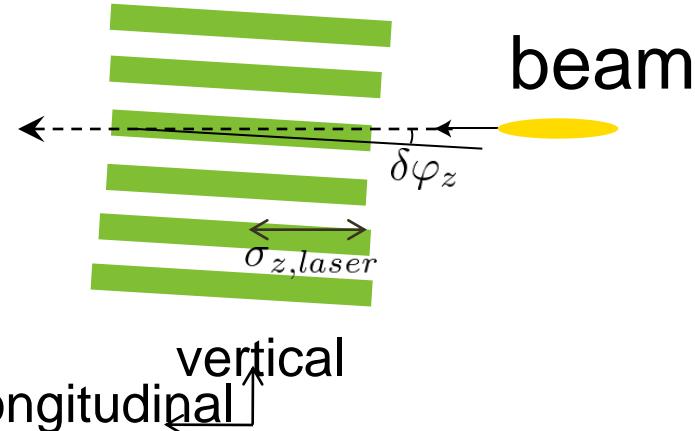
Shintake Monitor



Plan to monitor the tilt of  
laser fringe by 2 PSDs

The beam senses fringe pattern  
projected on transverse- and  
longitudinal-plane which the  
beam forms on.

fringe pattern



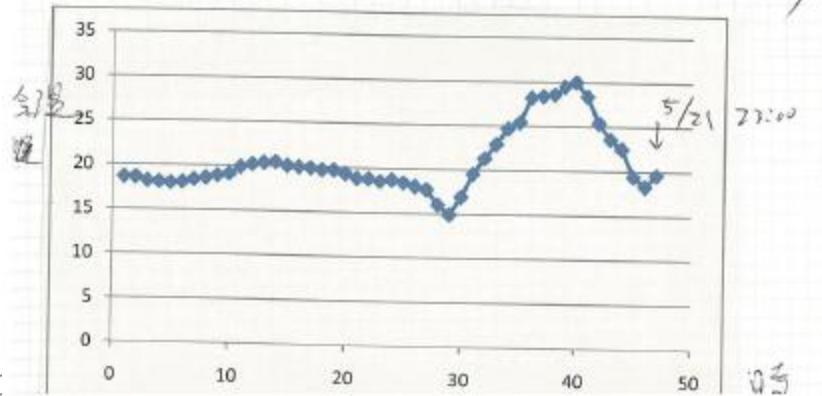
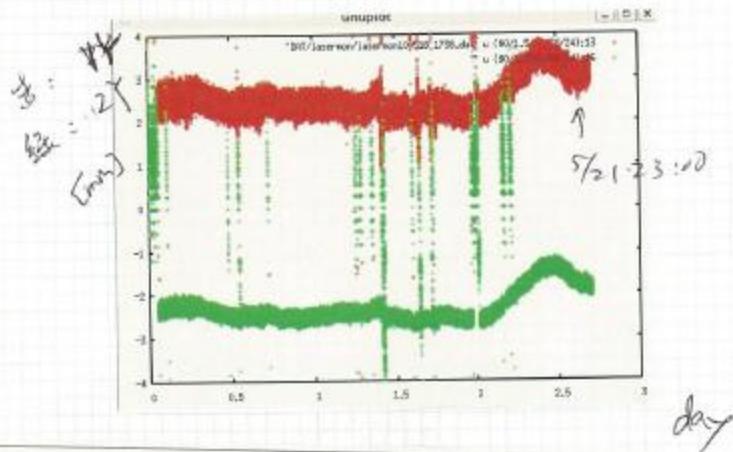
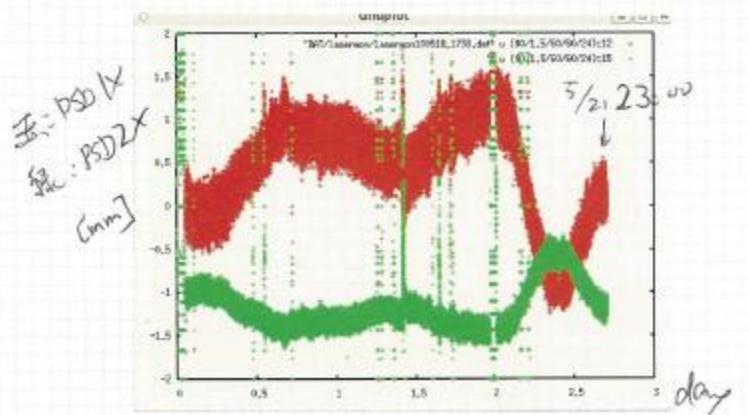
$$\sigma_{y,\text{meas.}}^2 = \sigma_{y,\text{ideal}}^2 + \delta\varphi_z^2 \sigma_{z,\text{laser}}^2$$

# Summary

- Until now, the measurement by 2- 8 deg.mode was done and systematic error sources were studied
- The current status and the upgrade plan was reported

# Backup

# 光路ドリフト

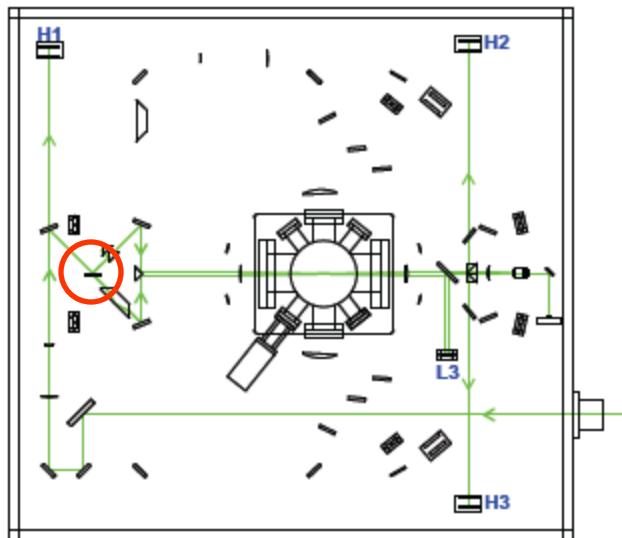


気温とともにlaser positionがドリフト

# Laser Polarization

P-polarized reflectance of the beam splitter is not 50%, since the splitter is tuned for S-polarized light. So the existence of P-polarized light causes power imbalance of the split laser beams and makes the fringe contrast worse.

$$C_{\text{pol}} = \frac{2 \left( \sqrt{P_s^{\text{up}} P_s^{\text{down}}} + \sqrt{P_p^{\text{up}} P_p^{\text{down}}} \right)}{P}$$



Ps: the intensity of S-polarized light  
 Pp: the intensity of P-polarized light  
 P: the whole intensity of laser

$$C_{\text{pol}} = 96.3 \pm 2.1\%$$

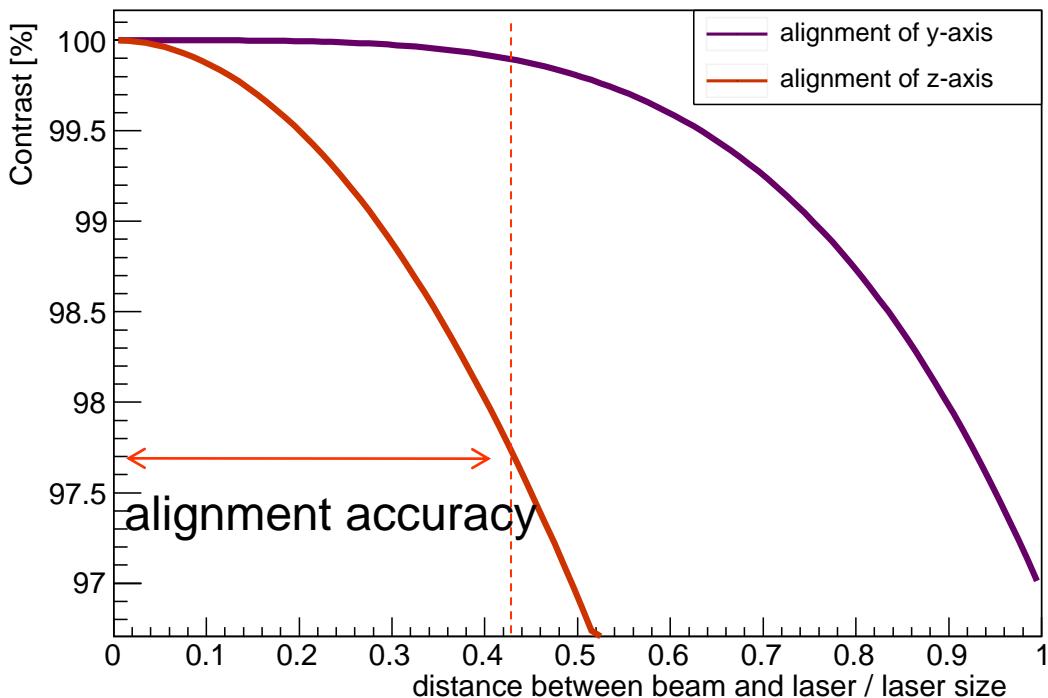
after polarization adjustment with half wave plate

$$C_{\text{pol}} = 99.7 \pm 0.1\%$$

# Laser Alignment Accuracy

It is important for a good contrast to align the laser pathway with beam position.

**laser alignment**

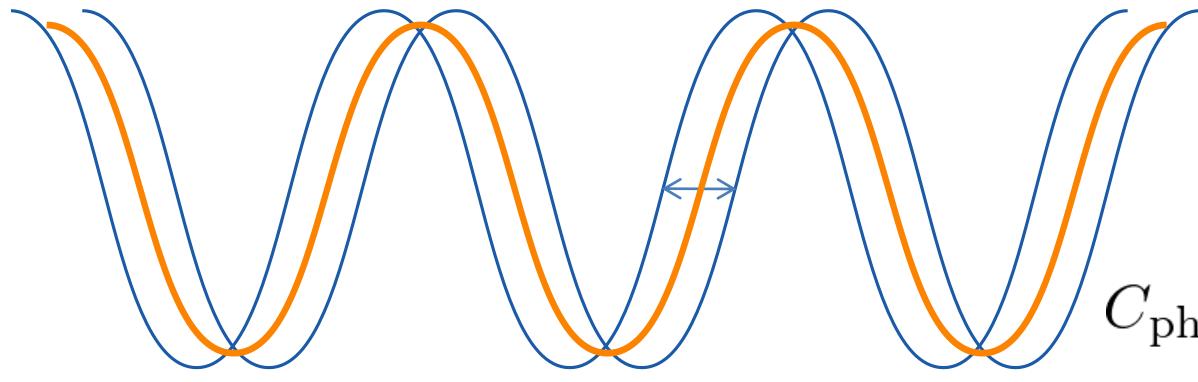


$$C_{\text{alignment}} > 97.5\%$$

# Phase Jitter

Phase jitter of the laser light smears the fringe pattern, and decreases modulation depth.

Phase jitter is caused by optical device vibrations.



$$C_{\text{phase}} = \exp \left( -\frac{\Delta \text{phase}^2}{2} \right)$$

The Shintake monitor has a phase monitor and a light path length feedback system with piezoelectric device.

Using the feedback system,

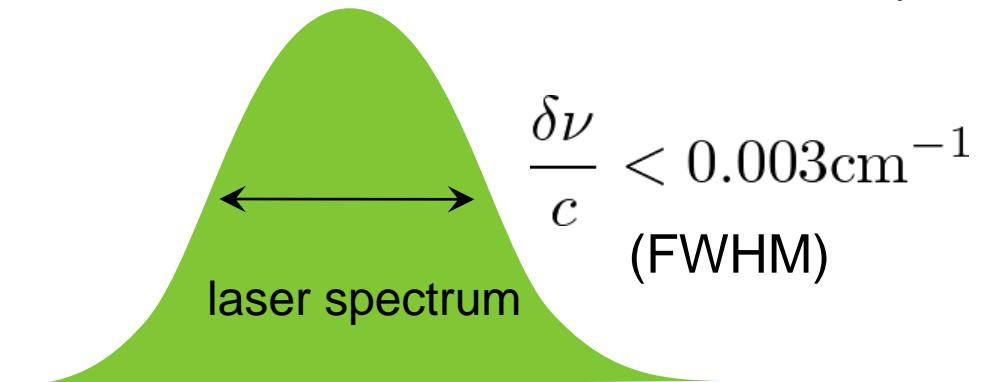
$$\Delta \text{phase} = 398 \pm 54 \text{ mrad} \rightarrow 320 \pm 41 \text{ mrad}$$

$$C_{\text{phase}} = 92.3 \pm 2.0\% \rightarrow 95.0 \pm 1.2\%$$

# Laser Temporal Coherence

- If the laser temporal coherence is poor and the two laser path lengths are different, the fringe pattern contrast is reduced.
- This is because each frequency component of the laser contributes to interference in different phase under the existence of laser path length difference  $\Delta l$ .

$$C_{\text{t-coherence}} = \exp \left( -\frac{\pi^2}{4 \ln 2} \left( \frac{\delta\nu \Delta l}{c} \right)^2 \right)$$

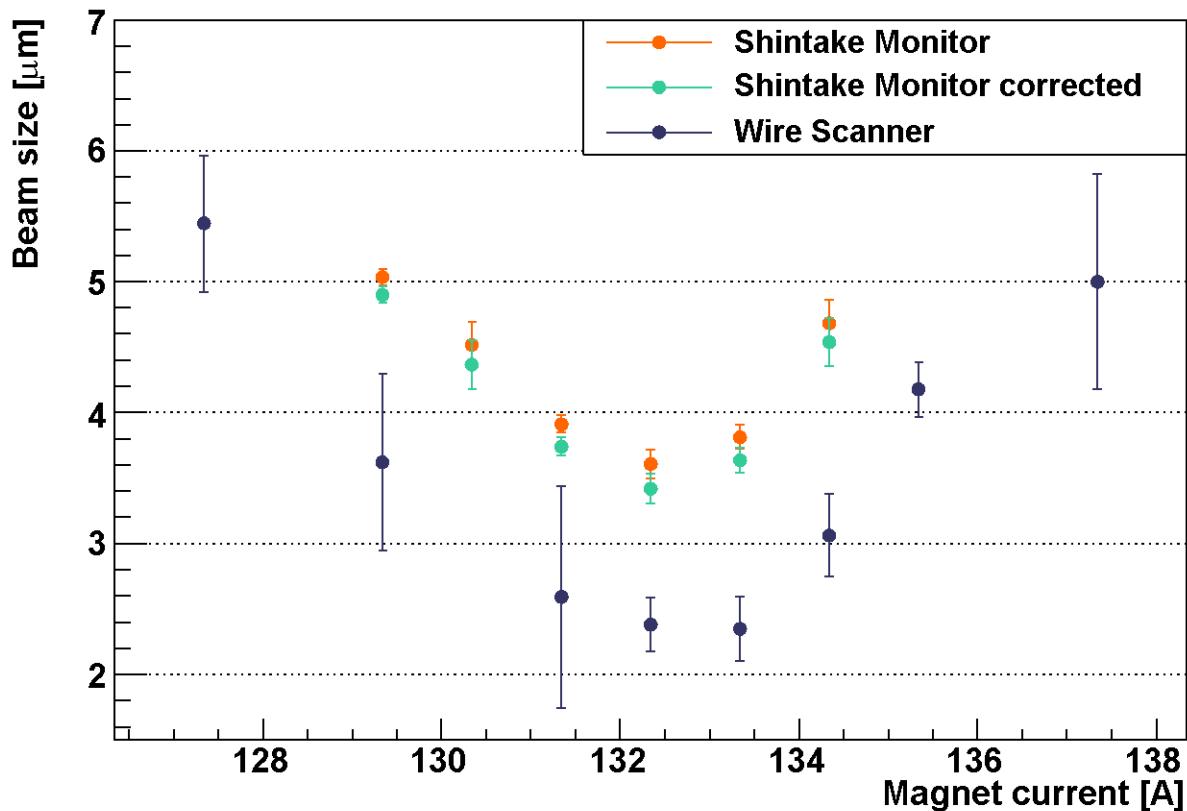


$$C_{\text{t-coherence}} > 99.7\%$$

# Contrast Correction

Comparison with the WS measurement after Contrast correction

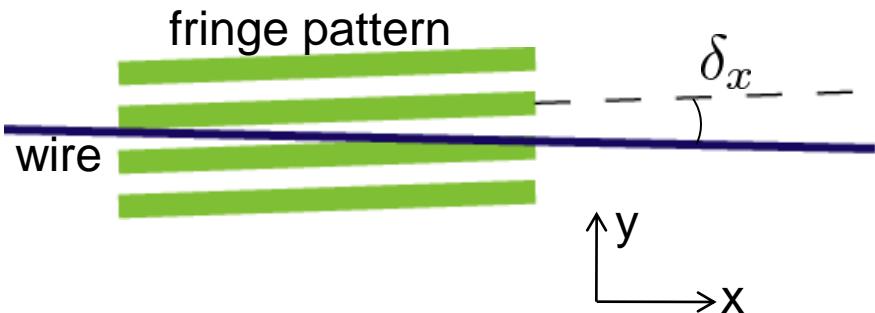
Quadrupole Defocusing Magnet Scan



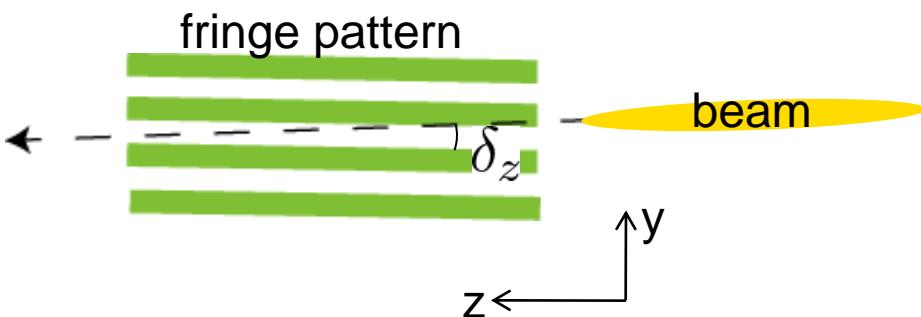
After the above corrections the measured beam size is slightly decreased, but systematic shift still remains.

# Tilt of the laser fringe pattern with respect to the WS

Horizontal and longitudinal axes defined by the WS and those defined by the fringe pattern might be different.



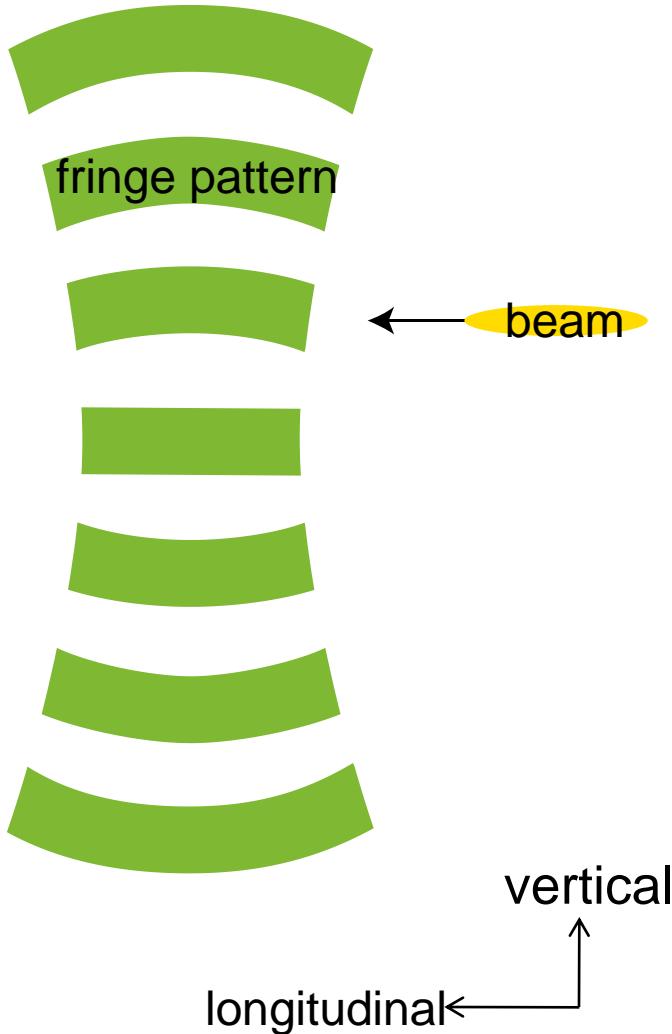
$$\sigma_{meas}^2 = \sigma_y^2 + \sigma_x^2 \delta_x^2 + \sigma_{laser}^2 \delta_z^2$$



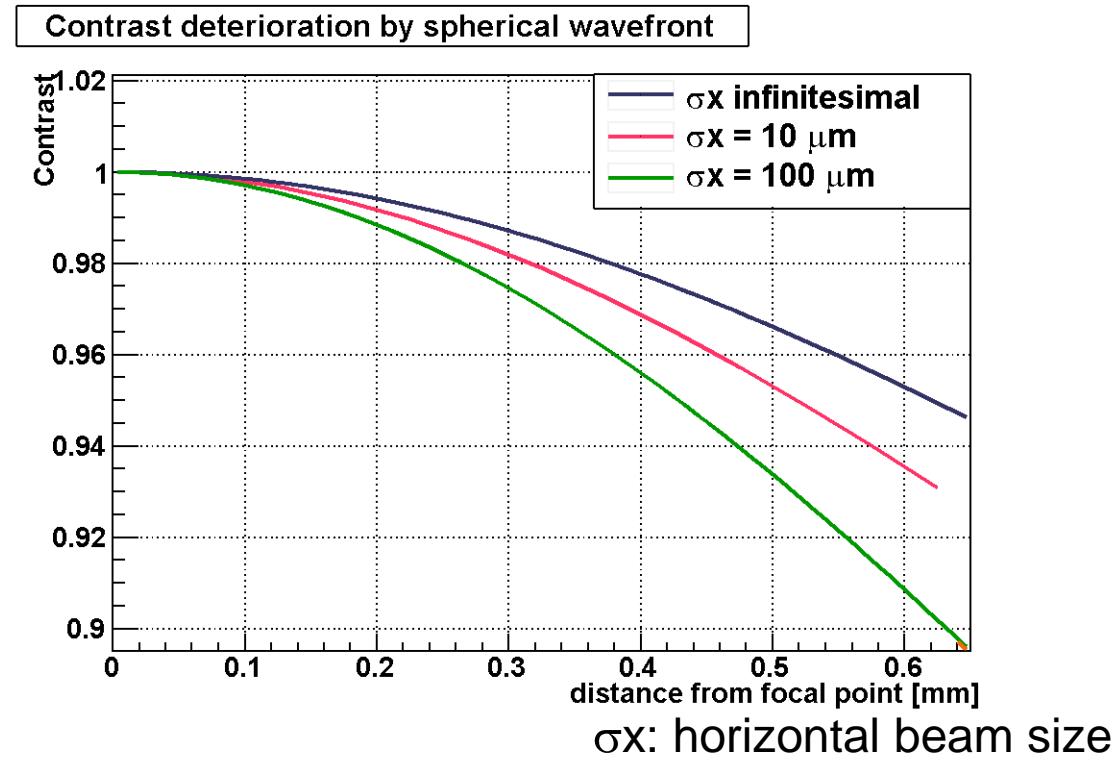
$\sigma_{meas}$	measured vertical beam size
$\sigma_y$	vertical beam size
$\sigma_x$	horizontal beam size
$\sigma_{laser}$	laser size

If  $\delta_x \sim 2$  degrees and  $\sigma_x \sim 50\mu\text{m}$ , the Shintake monitor and the WS has comparable measurement result.

# Laser Spherical Wavefront



If beam position is away from the laser focal point when beam pass the fringe pattern, beam senses courved fringe due to the laser spherical wavefront.



# Beam Size Growth in the Fringe

